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John J. Kelly, Jr.

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Examiner : Stefanie J. Cohen
Art Unit : 4162
Docket No. : 52433/861
Conf. No. : 7884

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : Jiro KONDO, et al.
Serial No. : 10/591,093
Filing Date : August 29, 2006
For : **METHOD FOR REMOVING BORON FROM SILICON**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

S I R:

Reconsideration of the above-identified patent application, as amended, is respectfully requested. The present amendment is responsive to the Office Action mailed July 28, 2008. A petition for an extension of time in which to respond to the Office Action accompanies this amendment.